

TFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q92479

Tsuyoshi UEHARA, et al.

Appln. No.: 10/565,004

Group Art Unit: 1762

Confirmation No.: 5166

Examiner: Not Yet Assigned

Filed: January 19, 2006

For:

PLASMA PROCESSING APPARATUS AND ELECTRODE STRUCTURE

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

ATTN: Office of Initial Patent Examination

Filing Receipt Correction Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction:

Assignment For Published Patent Application SEKISUI CHEMICAL CO., LTD.

Title

Plasma treating processing apparatus and its electrode structure

Verification for the requested correction is indicated on the Declaration and Power of Attorney and Assignment filed January 19, 2006.

Respectfully submitted,

SUGHRUE MION, PLLC

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WASHINGTON OFFICE

CUSTOMER NUMBER

Date: June 15, 2006

Alan J. Kasper

Registration No. 25,426



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FILING OR 371 APPL NO. ART UNIT FIL FEE REC'D ATTY.DOCKET NO **DRAWINGS** TOT CLMS IND CLMS (c) DATE 10/565,004 01/19/2006 1762 2650 Q92479 36 34

CONFIRMATION NO. 5166

23373 SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037

JOCKETE MAY 3 C 2006

FILING RECEIPT *OC000000018794341*

Date Mailed: 05/23/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Tsuyoshi Uehara, Kyoto, JAPAN: Takayuki Ono, Ibaraki, JAPAN; Hitoshi Sezukuri, Kyoto, JAPAN; Hiroto Takeuchi, Ibaraki, JAPAN; Hiromi Komiya, Kyoto, JAPAN; Takumi Ito, Kyoto, JAPAN;

Takae Ohta, Tokyo, JAPAN For Published SUI CHEMICA

Power of Attorney: The patent practitioners associated with Customer Number 23373.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/10415 07/22/2004

Foreign Applications

JAPAN 2003-278536 07/23/2003 JAPAN 2003-278537 07/23/2003 JAPAN 2003-342195 09/30/2003 JAPAN 2003-385691 11/14/2003 JAPAN 2004-080166 03/19/2004 JAPAN 2004-080167 03/19/2004 JAPAN 2004-214182 07/22/2004 JAPAN 2004-214183 07/22/2004

If Required, Foreign Filing License Granted: 05/13/2006

The country code and number of your priority application, to be used for filing abroad under the Paris

Convention, is **US10/565,004**

Projected Publication Date: 08/24/2006

Non-Publication Request: No

Early Publication Request: No

Title

Plasma treating apparatus and ite electrode structure

Preliminary Class

427

PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES

Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filing of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process **simplifies** the filing of patent applications on the same invention in member countries, but **does not result** in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

Applicants also are advised that in the case of inventions made in the United States, the Director of the USPTO must issue a license before applicants can apply for a patent in a foreign country. The filing of a U.S. patent application serves as a request for a foreign filing license. The application's filing receipt contains further information and guidance as to the status of applicant's license for foreign filing.

Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at http://www.uspto.gov/web/offices/pac/doc/general/index.html.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, http://www.stopfakes.gov. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

LICENSE FOR FOREIGN FILING UNDER
Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15

GRANTED



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Docket	No.:		

DECLARATION AND POWER OF ATTORNEY FOR UTILITY OR DESIGN PATENT APPLICATION (37 C.F.R. 1.63)

実用・意匠特許出願宣言書および委任状 (37 C.F.R. 1.63)

Japanese Language Declaration

私は以下の通り宣言します:	I hereby declare that:
各発明者の住所、郵送先、および国籍は下記氏名の後に 記載された通りです。	Each inventor's residence, mailing address, and citizenship are as stated below next to their name.
下記名称の発明に関し請求範囲に記載され特許出願がされている発明内容につき、下記に記載された発明者が本来かつ最初の発明者であると信じます。	I believe the inventor(s) named below to be the original and first inventor(s) of the subject matter which is claimed and for which a patent is sought on the invention entitled:
	PLASMA PROCESSING APPARATUS AND ELECTRODE STRUCTURE
□ 上記発明の明細書は本書に添付されます。	the specification of which is attached hereto
または	OR .
□ 上記発明は米国出願番号あるいは PCT 国際出願番号 □ (確認番号) として (年 月 日に出願され、	was filed on July 22, 2004 as United States Application Number or PCT International Application Number PCT/JP2004/010415 (Confirmation No), and was amended on(if applicable).
私は補正が上に明示された場合は補正された特許間求範 囲を含む前記明細書の内容を検討し、理解していること をここに表明します。	I hereby state that I have reviewed and understand the contents of the above identified specification, including the claims, as amended by any amendment specifically referred to above.
私は一部継続出願の場合先行出願の出願日から一部継続 出願の国内あるいは PCT 国際出願日までの期間中に入手 された重要な情報を含み、37 C.F.R. 1.56 に定義され る特許性に肝要な情報について関示義務があることを認 めます。	I acknowledge the duty to disclose information which is material to patentability as defined in 37 C.F.R. 1.56, including for continuation-in-part application(s), material information which became available between the filing date of the prior application and the national or PCT international filing date of the continuation-in-part application.

Japanese Language Declaration

私は35 U.S.C. 119 (a) - (d) あるいは(f), または365 (b) に基づき特許、発明者、あるいは植物育種家証書の下記外国出願、または365 (a) に基づきアメリカ合衆国以外の少なくとも1ヶ国を指定した下記PCT国際出願についての外国優先権特典をここに主張するとともに、下記項目にx印を付けることにより優先権を主張する出願以前の出願日を有する特許、発明者、あるいは植物育種家証書の外国出願またはPCT国際出願を示します。

効性を危うくする可能性があることを認識した上でこれ

らの陳述をなしたことを宣言します。

I hereby claim foreign priority benefits under 35 U.S.C. 119(a)-(d) or (f), or 365(b) of any foreign application(s) for patent, inventor's or plant breeder's rights certificate(s), or 365(a) of any PCT international application(s) which designated at least one country other than the United States of America, listed below and have also identified below, by checking the box, any foreign application(s) for patent, inventor's or plant breeder's rights certificate(s), or any PCT international application(s) having a filing date before that of the application on which priority is claimed.

		•		
Prior Foreign Application Numbe 先行外国出願番号	er(s)	•	優先権 Yes	Claimed? の主張 ? No
2003-278536	Japan	July 23, 2003	有り 図	無し口
(Application Number) (出願番号)	(Country) (国名)	(Filing Date) (出願日)		u
2003-278537	Japan	July 23, 2003	\boxtimes	
(Application Number) (出願番号)	(Country) (国名)	(Filing Date) (出願日)		ш
私は 35 U.S.C. 119(e)に基づき 内優先権をここに主張します。	: 下記の米国仮特許出願の国 。	I hereby claim domestic priority under 35 L United States provisional application(s) listed	J.S.C. 119(d below.	(e) of any
(Application Number) (出願番号)	(Filing Date) (出願日)	· .		
(Application Number) (出願番号)	(Filing Date) (出願日)			
私は 35 U.S.C. 120 に基づきは 365 (c) に基づき米国を指定益をここに主張し、本特許出の内容が 35 U.S.C. 112 の最より先行米国あるいは PCT Eない限りにおいて 37 C.F.R.の特許性に肝要で、先行特出願の国内あるいは PCT 国手された情報について開えす。	でする下記 PCT 国際出願の利 団際内特許請求範囲の各項目 最初の項に規定される方法に 国際特許出願で開示されてい 1.56 に定義される本出願 許出願の出願日から本特許 I際出願日までの期間中に入	I hereby claim benefit under 35 U.S.C. 120 application(s) or 365(c) of any PCT internates designating the United States, listed below subject matter of each of the claims of this disclosed in a listed prior United States or application in the manner provided by the 35 U.S.C. 112, I acknowledge my duty information material to the patentability of defined in 37 C.F.R. 1.56 which occurred date of the prior application and the international filing date of this application:	tional appl and, insoft is application of PCT interest para to disciple this application of this applications	ication(s) far as the fon is not ernational agraph of lose any ication as the filing
Prior U.S. or International Applic 先行米国あるいは国際出願番				
(Application Number) (出願番号)	(Filing Date) (出願日)	(Status: patented, pending, abandoned) (状態:特許成立済、係属中、放棄済)		
(Application Number) (出願番号)	(Filing Date) (出願日)	(Status: patented, pending, abandoned) (状態:特許成立済、係属中、放棄済)	<u> </u>	
私は本宣書掛内で私自身の知ての陳述が真実であり、情報いてなされたすべての陳述がることをここに宣言し、さら述等々は18 U.S.C. 1001 に基は両方による処罰にあたり、偽の陳述はそれに基づく特許	および信ずるところに基づ 臭実であると信じられてい に故意になされた虚偽の陳 もづき罰金あるいは拘禁また またかような故意による虚	I hereby declare that all statements made knowledge are true and that all statements n and belief are believed to be true; and statements were made with the knowledg statements and the like so made are pur imprisonment, or both, under 18 U.S.C. willful false statements may jeopardize application or any patent issued thereon.	nade on inf further the e that will nishable by 1001 and 1	formation hat these lful false y fine or that such

Japanese Language Declaration

委任状:私は下記の米国特許商標局(USPTO) 顧客番号のもとに記載される SUGIRUE MION 法律事務所のすべての弁護士を、同顧客番号のもとに記載される個々の弁護士は Sughrue Mion 法律事務所のみの自由裁量に基づき変更され得ることを認識した上で、本特許出願の手続きおよびそれに関わる米国特許商標局との業務を遂行する弁護士として指名し、本特許出願に関するすべての通信が同 USPTO 顧客番号のもとに提出された住所宛に送付されることを要請します。

POWER OF ATTORNEY: I hereby appoint all attorneys of SUGHRUE MION, PLLC who are listed under the USPTO Customer Number shown below as my attorneys to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith, recognizing that the specific attorneys listed under that Customer Number may be changed from time to time at the sole discretion of Sughrue Mion, PLLC, and request that all correspondence about the application be addressed to the address filed-under the same USPTO Customer Number.

STATEMENT OF ACCURATE TRANSLATION IN ACCORDANCE WITH 37 C.F.R. §1.69(b):

The declaration and power of attorney is an accurate translation of the corresponding English language declaration and power of attorney,

Signature _

Date

WASHINGTON OFFICE

23373 CUSTOMER NUMBER

電話連絡は下記へ:

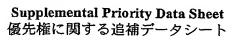
SUGHRUE MION, PLLC (202) 293-7060

Direct Telephone Calls to:

SUGHRUE MION, PLLC (202) 293-7060

NAME OF SOLE OR FIRST INVENTOR: 唯一あるいは第一の発明者名				
Given Name (first and middle [if any]) 名 (名およびミドルネーム[該当する場合]) Tsuyoshi	Family Name or Surname 姓 UEHARA			
Inventor's signature Tsuyoshi Vehara	Date 日付 November 14, 2005			
Residence: Citizenship 住所: Kyoto-shi, Kyoto, Japan 国籍 Japan				
Mailing Address: c/o SEKISUI CHEMICAL CO., LTD., 2-2, Kamichoshi-cho, Kamitoba, Minami-ku, Kyoto-shi, Kyoto 601-8105 郵送先: Japan				
NAME OF SECOND INVENTOR: 第二の発明者名:				
Given Name (first and middle [if any]) Family Name or Surname				
名 (名およびミドルネーム[該当する場合]) Takayuki	姓 ONO			
Inventor's signature Jakayuki Ono	Date 日付 November 14, 2005			
Residence: 住所: Tsukuba-shi , Ibaraki , Japan	Citizenship 国籍 Japan			
Mailing Address: 郵送先: c/o SEKISUI CHEMICAL CO., LTD., 32 Wadai, Tsukuba-shi, Ibaraki 300-4247 Japan				

NAME OF THIRD INVENTOR: 第三の発明者名:				
Given Name (first and middle [if any]) 名 (名およびミドルネーム[該当する場合]) Hitoshi	Family Name or Sum 姓	name SEZUKURI		
Inventor's signature 執 造 一 志		Date 日付 November 14, 2005		
Residence: 住所: Kyoto-shi , Kyoto , Japan		Citizenship 国籍 Japan		
Mailing Address: c/o SEKISUI CHEMICAL CO., LTD., 2-2, Kamichon Japan	shi-cho, Kamitoba, Min	ami-ku, Kyoto-shi, Kyoto 601-8105		
NAME OF FOURTH INVENTOR: 第四の発明者名:				
Given Name (first and middle [if any]) 名 (名およびミドルネーム[該当する場合]) Hiroto	Family Name or Sum 姓	name TAKEUCHI		
Inventor's signature 発明者の署名 「一」	I	Date 目付 November 14, 2005		
Residence: 住所: Tsukuba-shi , Ibaraki , Japan		Citizenship 国籍 Japan		
Mailing Address: 郵送先: c/o SEKISUI CHEMICAL CO., LTD., 32 Wadai, Tsu	ıkuba-shi, Ibaraki 300-4			
NAME OF FIFTH INVENTOR: 第五の発明者名:				
Given Name (first and middle [if any]) 名 (名およびミドルネーム[該当する場合]) Hiromi	Family Name or Sum 娃	name KOMIYA		
Inventor's signature 発明者の署名	•	Date 日付 November 14, 2005		
Residence: 住所: Kyoto-shi , Kyoto , Japan		Citizenship 国籍 Japan		
Mailing Address: c/o SEKISUI CHEMICAL CO., LTD., 2-2, Kamichoshi-cho, Kamitoba, Minami-ku, Kyoto-shi, Kyoto 601-8105 剪送先: Japan				
NAME OF SIXTH INVENTOR: 第六の発明者名:				
Given Name (first and middle [if any]) 名 (名およびミドルネーム[該当する場合]) Takumi	Family Name or Sum 姓	name ITO		
Inventor's signature 発明者の署名 人子 議 ゴ		Date 日付 November 14, 2005		
Residence: 住所: Kyoto-shi , Kyoto , Japan		Citizenship 国籍 Japan		
Mailing Address: c/o SEKISUI CHEMICAL CO., LTD., 2-2, Kamichoshi-cho, Kamitoba, Minami-ku, Kyoto-shi, Kyoto 601-8105 郵送先: Japan				
NAME OF SEVENTH INVENTOR: 第七の発明者名:				
Given Name (first and middle [if any]) 名 (名およびミドルネーム[該当する場合]) Takae	Family Name or Surr	name OHTA		
Inventor's signature Date				
Residence: 住所: Minato-ku, Tokyo, Japan		Citizenship 国籍 Japan		
Mailing Address: 郵送先: c/o SEKISUI CHEMICAL CO., LTD., 3-17, Toranon	non 2-chome. Minato-k	Japan		



Japan Jap	Application Number(s) 出願番号	Country 国名	F	iling Date 出願日		Claimed? D主張? No 無し
出願日 出願日 dditional U.S. or International applications: 加的米国または国際出願: Application Number(s) Filing Date Status: patented, pending, abando	03-342195 03-385691 04-080166 04-080167 04-214182 04-214183	Japan Japan Japan Japan	November 14, March 19, 200 March 19, 200 July 22, 2004	200 3 4		
lditional U.S. or International applications: 加的米国または国際出願: Application Number(s) Filing Date Status: patented, pending, abando	加的仮出願: Application Nun	nber(s)				
Application Number(s) Filing Date Status: patented, pending, abando		applications:				
	Application Number(s)			Status: pa (状態:特	tented, pending, a 許成立済、係属中	bandoned 、放棄済

Docket No	
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Assignment

Whereas, I/We, Tsuyoshi UEHARA of c/o SEKISUI CHEMICAL CO., LTD., 2-2, Kamichoshi-cho, Kamitoba, Minami-ku, Kyoto-shi, Kyoto 601-8105 Japan, Takayuki ONO of c/o SEKISUI CHEMICAL CO., LTD., 32 Wadai, Tsukuba-shi, Ibaraki 300-4247 Japan, Hitoshi SEZUKURI of c/o SEKISUI CHEMICAL CO., LTD., 2-2, Kamichoshi-cho, Kamitoba, Minami-ku, Kyoto-shi, Kyoto 601-8105 Japan, Hiroto TAKEUCHI of c/o SEKISUI CHEMICAL CO., LTD., 32 Wadai, Tsukuba-shi, Ibaraki 300-4247 Japan, Hiromi KOMIYA of c/o SEKISUI CHEMICAL CO., LTD., 2-2, Kamichoshi-cho, Kamitoba, Minami-ku, Kyoto-shi, Kyoto 601-8105 Japan, Takumi ITO of c/o SEKISUI CHEMICAL CO., LTD., 2-2, Kamichoshi-cho, Kamitoba, Minami-ku, Kyoto-shi, Kyoto 601-8105 Japan, and Takae OHTA of c/o SEKISUI CHEMICAL CO., LTD., 3-17, Toranomon 2-chome, Minato-ku, Tokyo 105-8450 Japan, respectively, hereinafter called assignor(s), have invented certain improvements in PLASMA PROCESSING APPARATUS AND ELECTRODE STRUCTURE
and executed an application for Letters Patent of the United States of America therefor on November 14, 2005; and

Whereas, SEKISUI CHEMICAL CO., LTD., 4-4, Nishitemma 2-chome Kita-ku, Osaka-shi, Osaka 530-8565 Japan (assignee), desires to acquire the entire right, title, and interest in the application and invention, and to any United States patents to be obtained therefor;

Now therefore, for valuable consideration, receipt whereof is hereby acknowledged,

I/We, the above named assignor(s), hereby sell, assign and transfer to the above named assignee, its successors and assigns, the entire right, title and interest in the application and the invention disclosed therein for the United States of America, including the right to claim priority under 35 U.S.C. §119, and I/we request the Director of the U.S. Patent and Trademark Office to issue any Letters Patent granted upon the invention set forth in the application to the assignee, its successors and assigns; and I/we will execute without further consideration all papers deemed necessary by the assignee in connection with the United States application when called upon to do so by the assignee.

I/We hereby authorize and request our attorneys SUGHRUE MION, PLLC of 2100 Pennsylvania Avenue, NW, Washington, DC 20037-3213 to insert here in

parentheses (Application number and Confirmation number, filed) the application number and filing date of said application when				
knowr				
Date:	November 14, 2005	Signature Tsuyoshi UEHARA		
. •		Signature Tsuyoshi UEHARA		
Date:	November 14, 2005	Takayuki Ono		
•		Signature: Takayuki ONO		
Date:	November 14, 2005	勢造-志		
		Signature: Hitoshi SEZUKURI		
Date:	November 14, 2005	竹内 裕人		
		Signature: Hiroto TAKEUCHI		
Date:	November 14, 2005	小宫広実		
		Signature: Hiromi KOMIYA		
Date:	November 14, 2005	月 版 巧 Signature: Takumi ITO		
		Signature Taxumi IIO		
Date:	November 14, 2005	Takae Ohta		
		Signature: Takae OHTA		